



Docket No.: 5916/FET/FET/DV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Application of

Young Joseph PAIK

Serial No. 09/998,384

Filed: November 30, 2001

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: Group Art Unit:
:
: Examiner:
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For: FEEDFORWARD AND FEEDBACK CONTROL FOR CONDITIONING OF
CHEMICAL MECHANICAL POLISHING PAD

**REQUEST FOR CHANGE OF CORRESPONDENCE ADDRESS
AND CHANGE OF ATTORNEY DOCKET NUMBER**

Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

The undersigned Principal Attorney of record hereby requests that **all correspondence** for
the above-identified patent application be directed to the following address:

Patent Counsel, MS/2061
Legal Affairs Department
Applied Materials, Inc.
P.O. Box 450A
Santa Clara, CA 95052

The undersigned Principal Attorney of record also respectfully requests that the Attorney
Docket Number of the application be changed to **5916/FET/FET/DV**.

Respectfully submitted,

HALE AND DORR LLP

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